



STALLMAN & POLLOCK LLP
121 Spear Street, Suite 290
San Francisco, CA 94105
(415) 512-1312

Atty Docket No. SCP-5020

Patent Application of: TAMER ELSAWY ET AL.

Application No.: 09/905,025

Filed: July 13, 2001

For: VAPOR DRYING SYSTEM AND METHOD

Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmittal herewith is an Preliminary Amendment in the above-identified application.

The fee has been calculated as shown below.

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	134	MINUS	50	84	x \$18 =	\$1512
INDEP.	16	MINUS	7	9	x \$84 =	\$756
FIRST PRESENTATION OF MULTIPLE DEP CLAIMS					+ \$280	\$
					TOTAL	\$2268

Small Entity 50% Filing Fee Reduction (if applicable) \$

* If the entry in Col. 1 is less than the entry in Col. 2, write "0" in Col. 3
** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.
*** If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space. The "Highest Number Previously Paid For" (Total or Independent is the highest number found from the equivalent box in Col. 1 of a prior amendment or the number of claims originally filed.)

- ☐ No additional fee is required.
- ☒ A check in the amount of \$2268 is attached.
- ☒ Please charge any additional fees, including any fees necessary for extensions of time or credit overpayment to Deposit Account No. 50-1703, under Order No. SCP-5020.
A duplicate copy of this sheet is enclosed.
- ☐ Petition for extension of time. The undersigned attorney of record hereby petitions for an extension of time pursuant to 37 C.F.R. § 1.136(a), as may be required, to file this response.

STALLMAN & POLLOCK LLP

Dated: 11.26.01

By: Kathleen A. Frost
Kathleen A. Frost (Reg. No. 37,326)
Attorneys for Applicant(s)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on November 26, 2001.

Dated: November 26, 2001

By: Janet Chan
Janet Chan

PATENT

-1-

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

TAMER ELSAWY ET AL.

Application No.: 09/905,025

Filed: July 13, 2001

For: VAPOR DRYING SYSTEM AND
METHOD

Group Art Unit: 1746

Examiner: Shamim Ahmed

PRELIMINARY AMENDMENT

121 Spear Street, Suite 290
San Francisco, CA 94105
(415) 512-1312

3A
BT
8/14/02

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited
with the United States Postal Service as First Class Mail in an
envelope, addressed to: Commissioner for Patents,
Washington, DC 20231 on November 26, 2001.

STALLMAN & POLLOCK LLP

Dated: 11/26/01 By: [Signature]

Janet Chan

Commissioner for Patents
Washington, D.C. 20231

Sir:

Please enter the following preliminary amendments prior to examining the referenced
application.

IN THE CLAIMS:

✓
Please cancel Claims 1-50.

✓
Please add new Claims 51-185.

RECEIVED
JAN 07 2002
TC 1700

51. (New) A method of treating and drying the surface of an object, comprising the steps of:

- (a) providing a system containing a vessel and at least one object having a surface;
- (b) exposing the object to a process fluid in the vessel;
- (c) performing a quick dump to discharge the process fluid from the vessel, leaving residual process fluid on the surface of the object;
- (d) after discharging the process fluid from the vessel, introducing a drying vapor into the system, the drying vapor condensing on the surface of the object and reducing the surface

01/04/2002 HND0R1 00000046 09905025

01 FC:102
02 FC:103

756.00 OP

Atty Docket No.: 3870-9020